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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/707,737	01/08/2004	Ching-Yu Chang	9563-US-PA-1	1736	
31561 7.	590 04/01/2005		EXAM	INER	
JIANQ CHYUN INTELLECTUAL PROPERTY OFFICE 7 FLOOR-1, NO. 100 ROOSEVELT ROAD, SECTION 2			HUYNH, ANDY		
			ART UNIT	PAPER NUMBER	
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TAIWAN			DATE MAILED: 04/01/200:	DATE MAILED: 04/01/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/707,737	CHANG, CHING-YU				
Office Action Summary	Examiner	Art Unit				
	Andy Huynh	2818				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).						
Status						
1) Responsive to communication(s) filed on <u>08</u>	1) Responsive to communication(s) filed on <u>08 January 2004</u> .					
2a) ☐ This action is FINAL. 2b) ☒ Th	This action is FINAL. 2b)⊠ This action is non-final.					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
 4) Claim(s) 1-6 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. 5) Claim(s) is/are allowed. 6) Claim(s) 1-6 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or election requirement. 						
Application Papers						
9)☐ The specification is objected to by the Examir	ner.					
10)⊠ The drawing(s) filed on <i>08 January 2004</i> is/are: a)⊠ accepted or b)□ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119						
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 						
Attachment(s)						
1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413) Paper No(s)/Mail Date						
Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0 Paper No(s)/Mail Date		ate Patent Application (PTO-152)				

Art Unit: 2818

DETAILED ACTION

Claims 1-6 are currently pending in this application. This application is a Divisional of Application No. 10/065,431 filed 10/17/2002 USPAT 6,720,210 is acknowledged.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

Claims 1, 3 and 5 are rejected under 35 U.S.C. 102(e) as being anticipated by Chang et al. (US Pub. No. 2003/0205770 dated 11/06/2003 filed 06/07/2002 hereinafter referred to as "Chang").

Regarding claims 1 and 3, Chang discloses in Figs. 2E-4 and the corresponding texts as set forth in [0030]-[0041], a mask read-only-memory (ROM) structure, comprises:

- a substrate 200;
- a buried bit line 202, 202a embedded inside the substrate;
- a patterned stack layer 204, 206, 208 covering a portion of the upper surface of the substrate, wherein the stack layer comprises a first dielectric layer/a silicon oxide layer 204, a stopping layer/a silicon nitride 206 and a second dielectric layer/a silicon oxide 208;
 - a gate oxide layer 204 covering a portion of the upper surface of the substrate; and

Art Unit: 2818

a word line 214 crossing over the buried bit line to form a plurality of coding cells, wherein the coding cells having a stack layer thereon are at a first data state while the coding cells having a gate oxide layer thereon are at a second data state (Fig. 2E, [0034]).

Regarding claim 5, Chang discloses the silicon nitride layer has a thickness between about 50Å to 70Å ([0032]).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 2, 4 and 6 are rejected under 35 U.S.C. 103(a) as being unpatentable over Chang et al. (US Pub. No. 2003/0205770 dated 11/06/2003 filed 06/07/2002 hereinafter referred to as "Chang").

Regarding claim 2, Chang discloses the claimed limitations except for the stack layer includes a silicon oxynitride layer. However, it would have been obvious to one having ordinary skill in the art at the time of the invention was made to form the stack layer includes a silicon oxynitride layer, since it has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability for the intended use as a matter of obvious design choice. In re Leshin, 125 USPQ 416.

Art Unit: 2818

Regarding claims 4 and 6, Chang discloses the claimed limitations except for the first and second dielectric layers have a thickness between about 200Å to 800Å. It would have been obvious to one of ordinary skill in the art at the time of the invention was made to form the first and second dielectric layers have a thickness between about 200Å to 800Å, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or working ranges involves only routine skill in the art. In re Aller, 105 USPQ 233.

Conclusion

A shortened statutory period for response to this action is set to expire 3 (three) months and 0 (zero) day from the day of this letter. Failure to respond within the period for response will cause the application to become abandoned (see M.P.E.P 710.02(b)).

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andy Huynh, (571) 272-1781. The examiner can normally be reached on Monday-Friday from 8:30 AM to 5:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The Fax number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the -status of this application or proceeding should be directed to the receptionist whose phone number is (703) 308-0956.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

Art Unit: 2818

Page 5

applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Ah

Andy Huynh

03/28/05

Patent Examiner